

Beam quality and stability improvements for a single-cell photo-cathode RF gun

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Characteristics of Spring-8 RFgun

1. Laser

THG of Ti:Sa Laser (266 nm, 10Hz, 200 μ J/pulse@nominal)

Spatial profile ----> Spatial filter & Homogenizer

Temporal distribution ----> Stretched with a SiO₂ glass rods

Energy stability ----> 2% with Homogenizer & Pinhole

2 RF cavity

S-band (2856MHz), Single-cell pill-box type cavity

Cu cathode

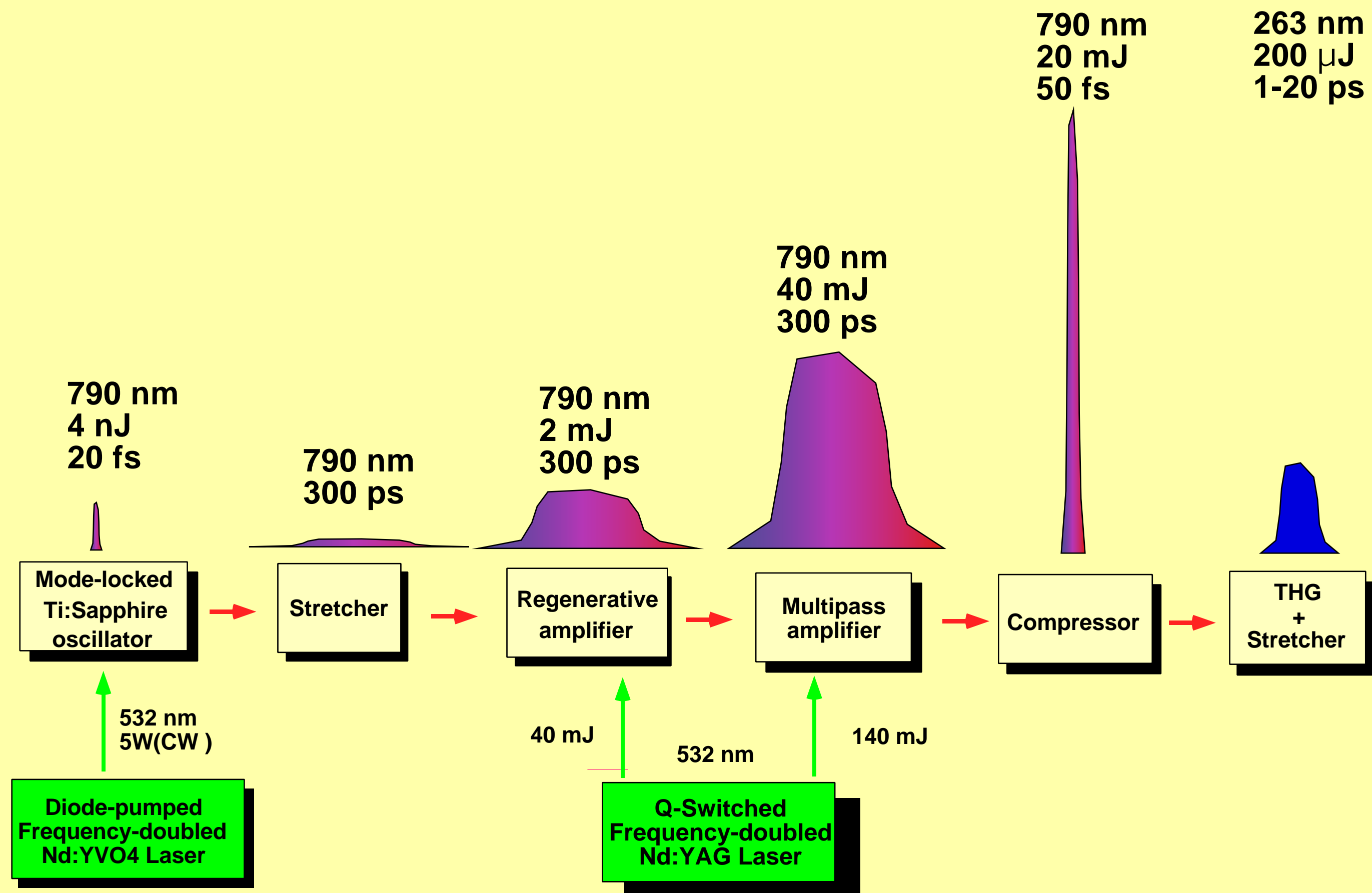
High electric field ----> 175 MV/m (@4.1 MeV)

3 Synchronization between Laser & RF

RF generation from laser pulses(89.25 MHz \pm 0.08Hz)

RMS jitter = 1.7 ps

Configuration of Laser System



Improvement of Laser System

1. Environments

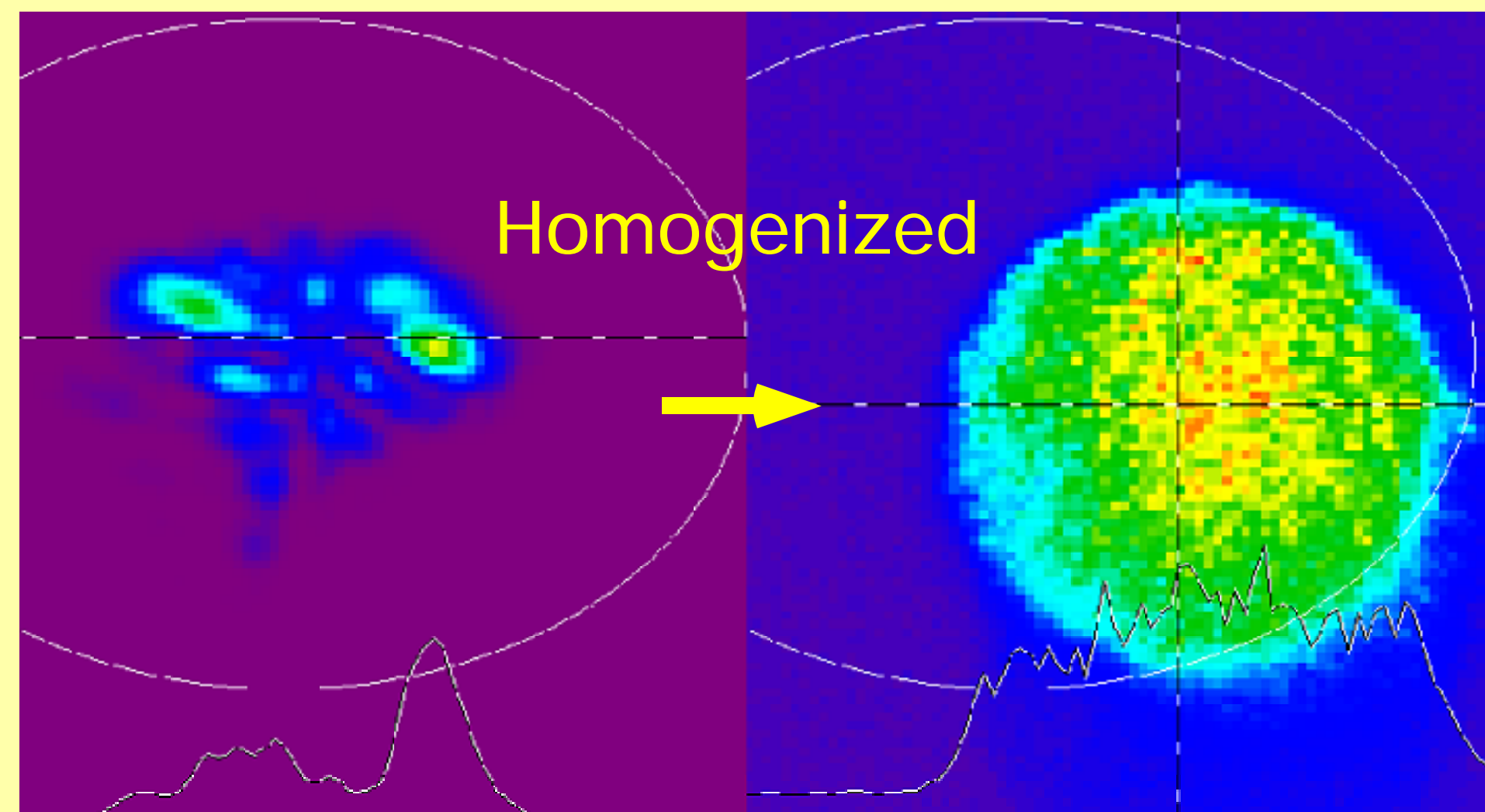
Improved cooling system of oscillator--> long-time operation

Decreased Air flow ----> Low-energy fluctuation of regen amp

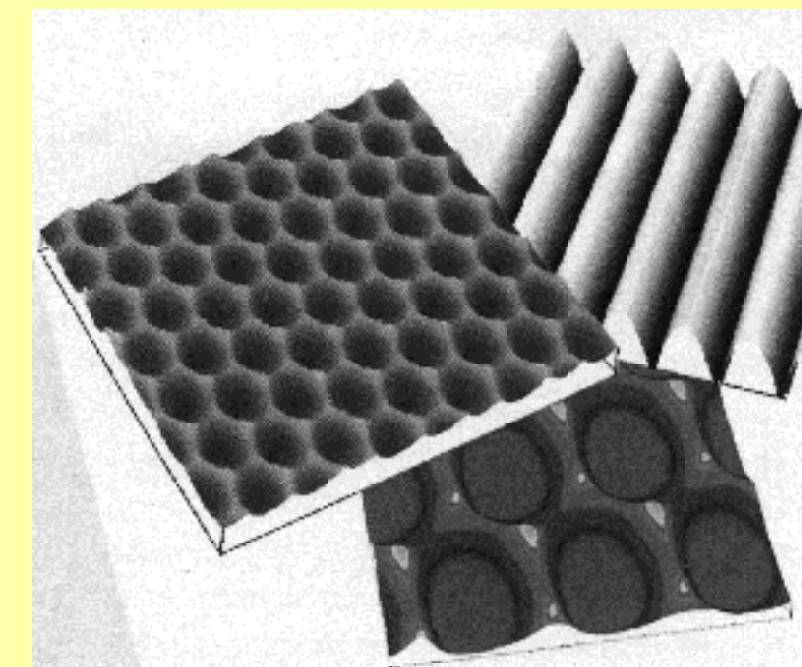
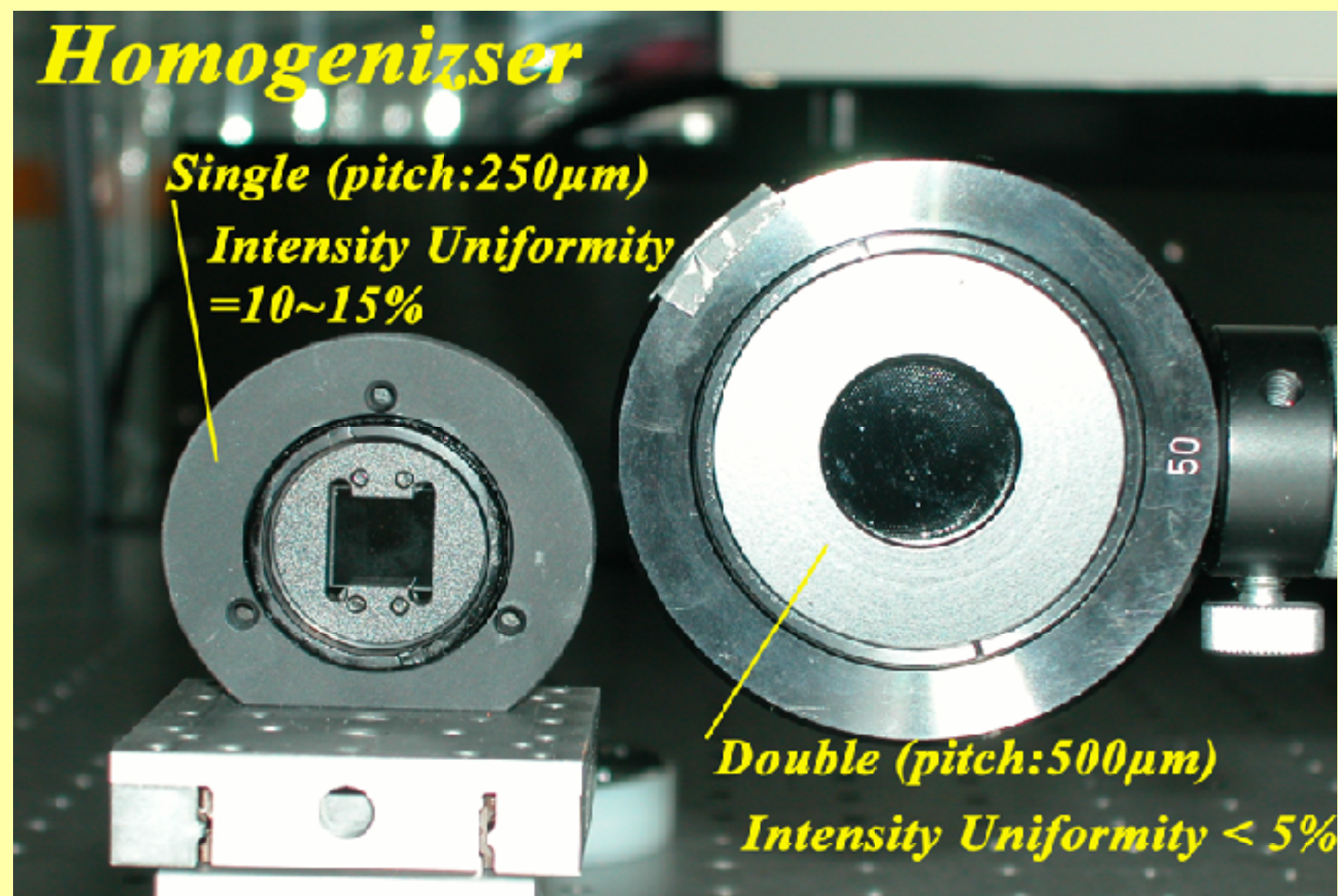
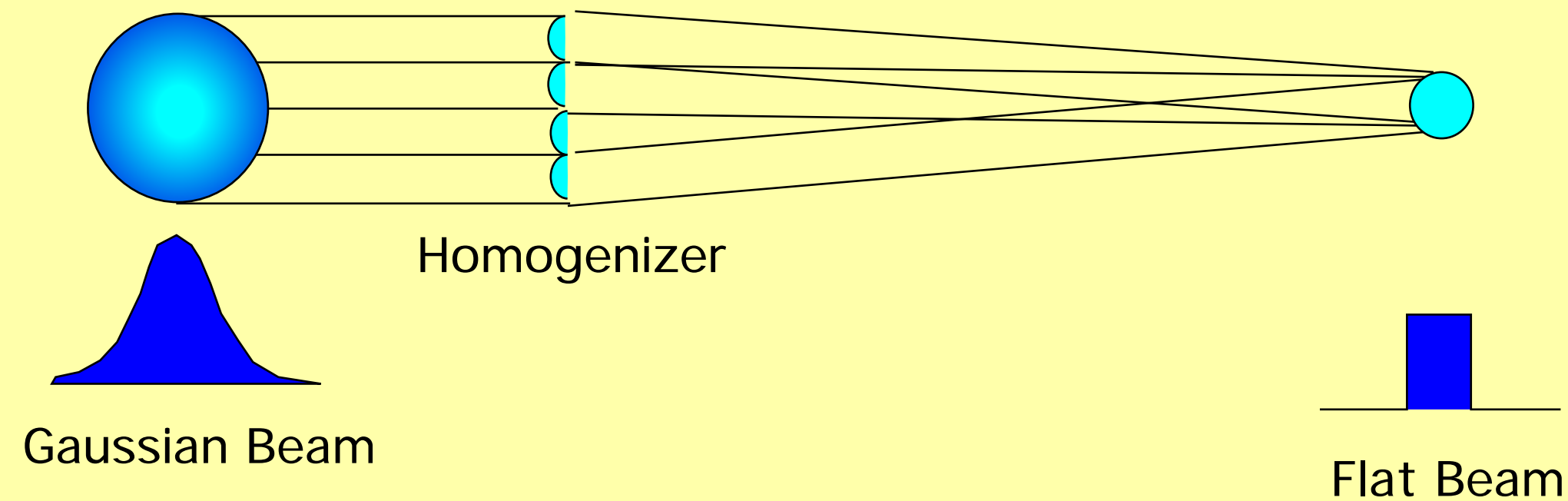
2 Laser Profile Improvements

Alignment of multi-path amplifier

Apply a microlens arrays as a spatial homogenizer

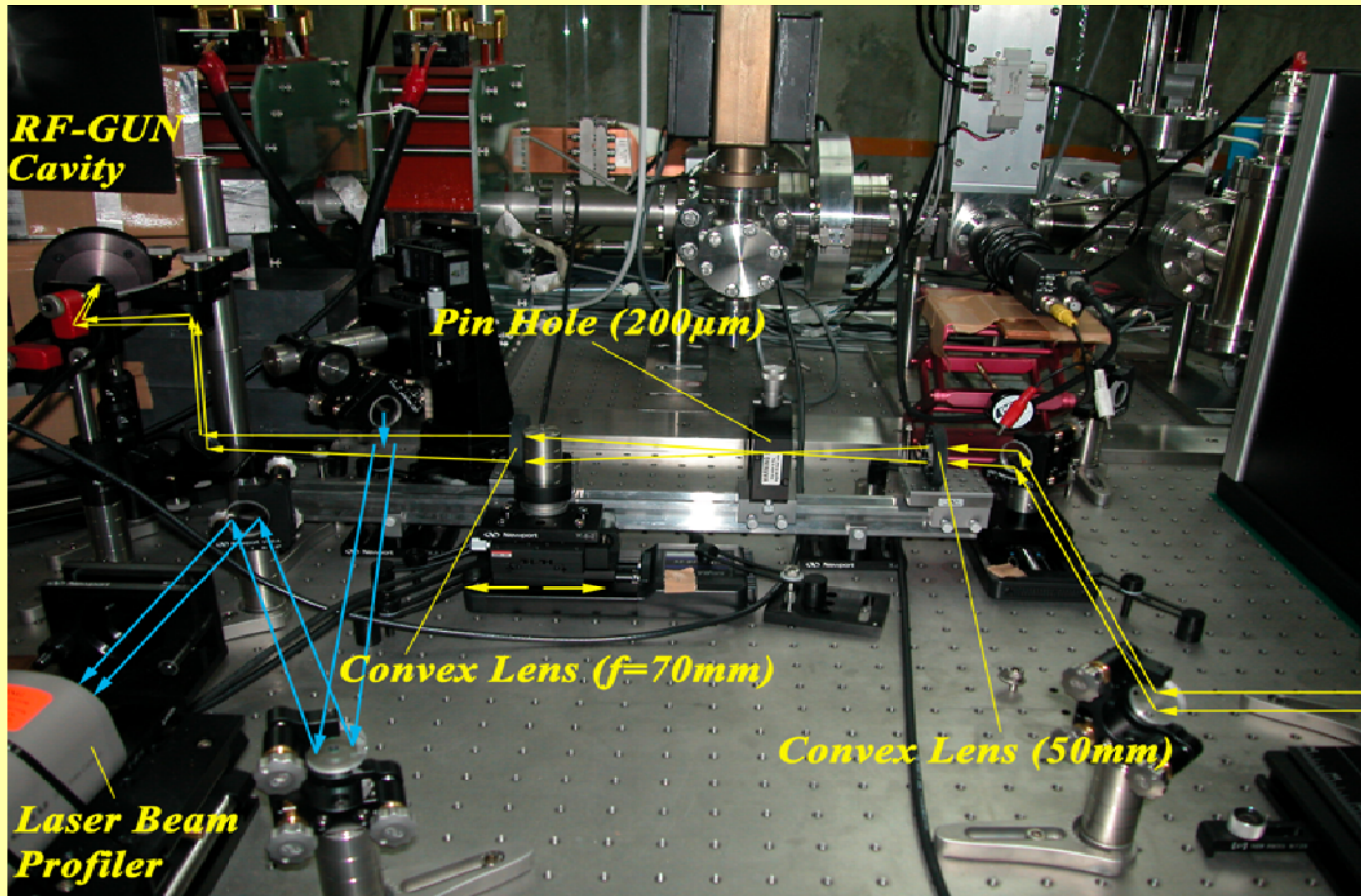


Homogenizer (microlens array)

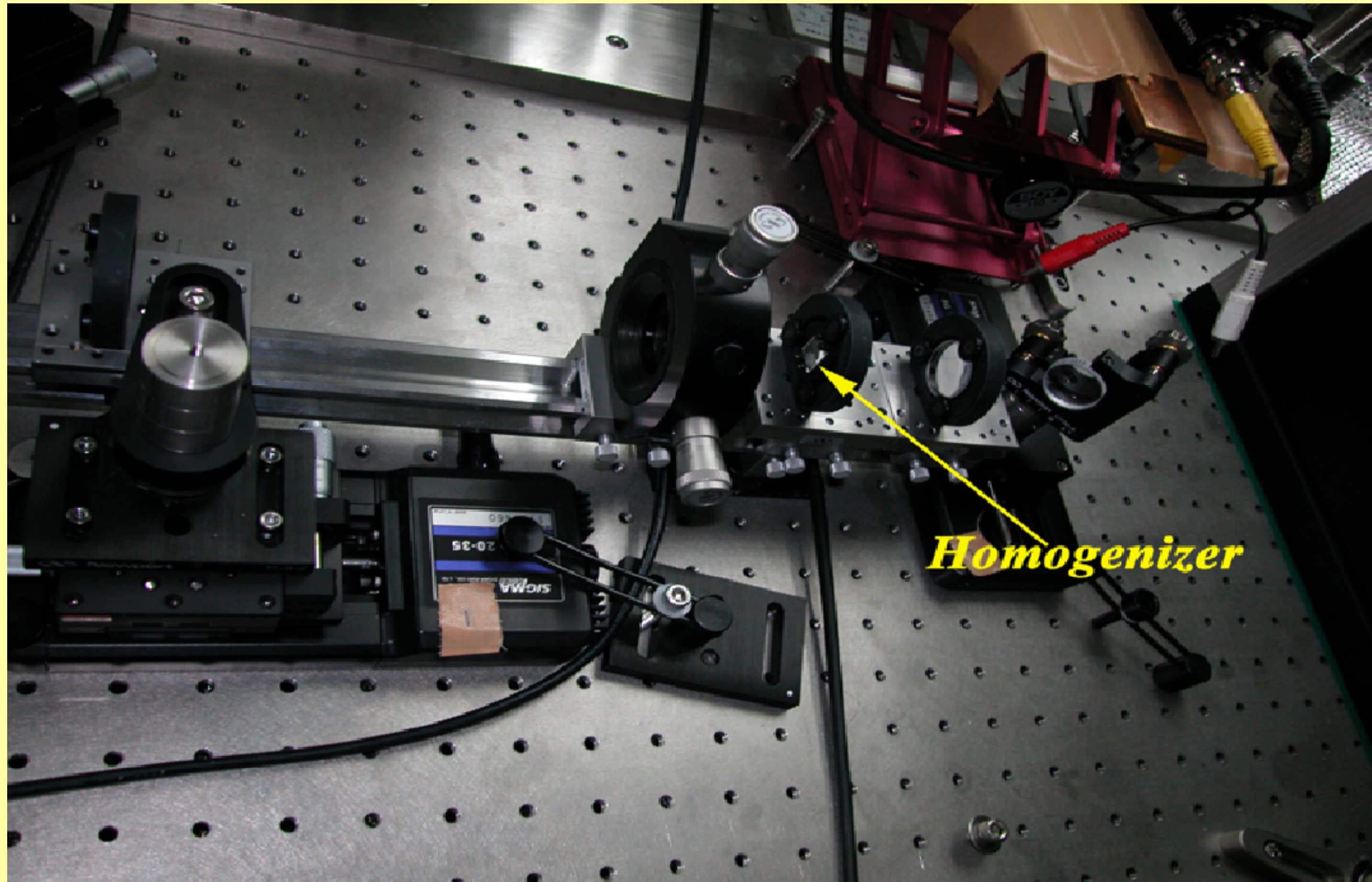


micro structure of Homogenizer

UV Laser Transport and Diagnostics (before Homogenizer installed)



Installation of Homogenizer



Improvements of Laser Profile & Beam Emittance

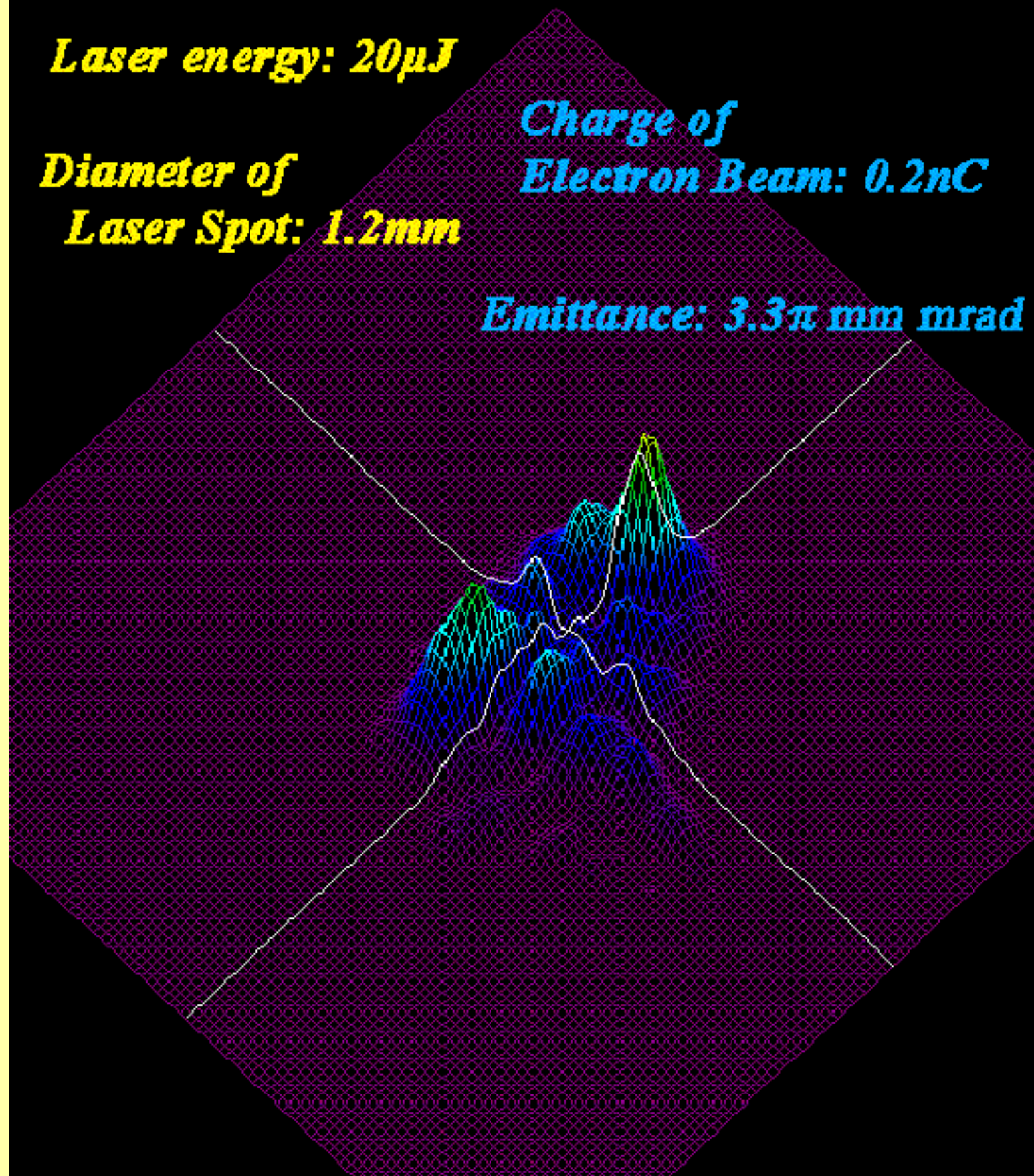
UV-Laser Profile

Laser energy: 20 μ J

**Diameter of
Laser Spot: 1.2mm**

**Charge of
Electron Beam: 0.2nC**

Emittance: 3.3 π mm mrad



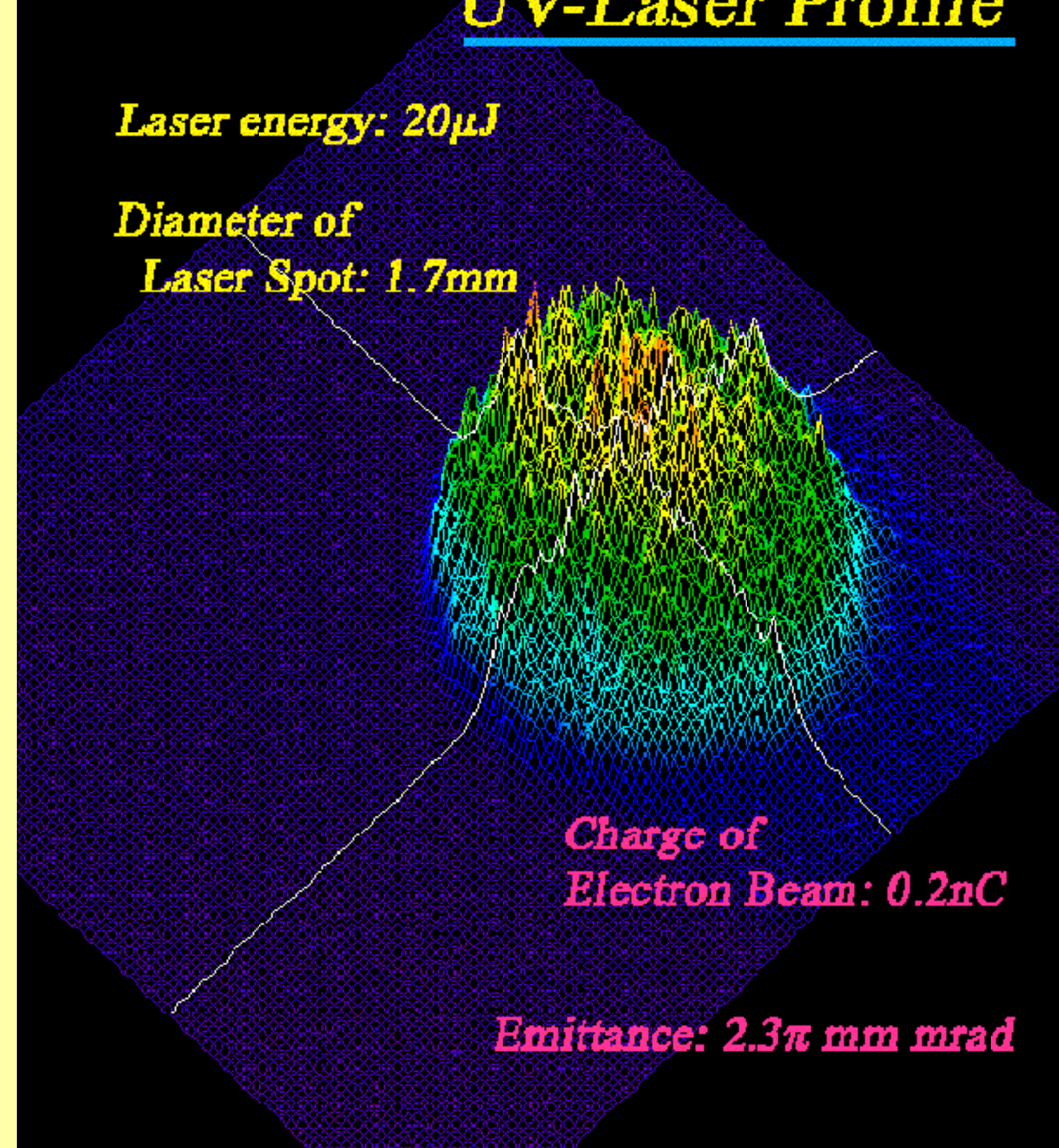
Homogenized UV-Laser Profile

Laser energy: 20 μ J

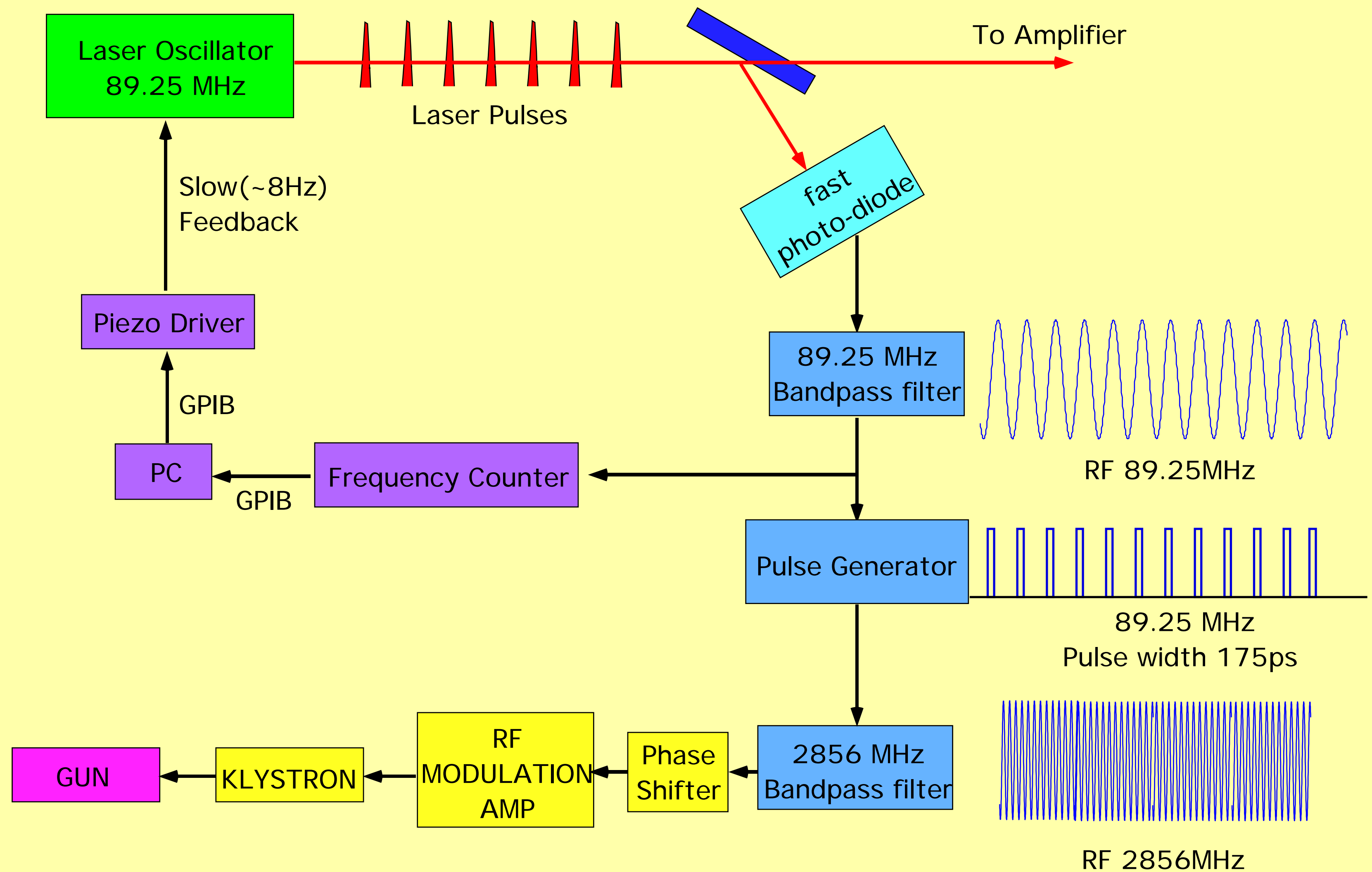
**Diameter of
Laser Spot: 1.7mm**

**Charge of
Electron Beam: 0.2nC**

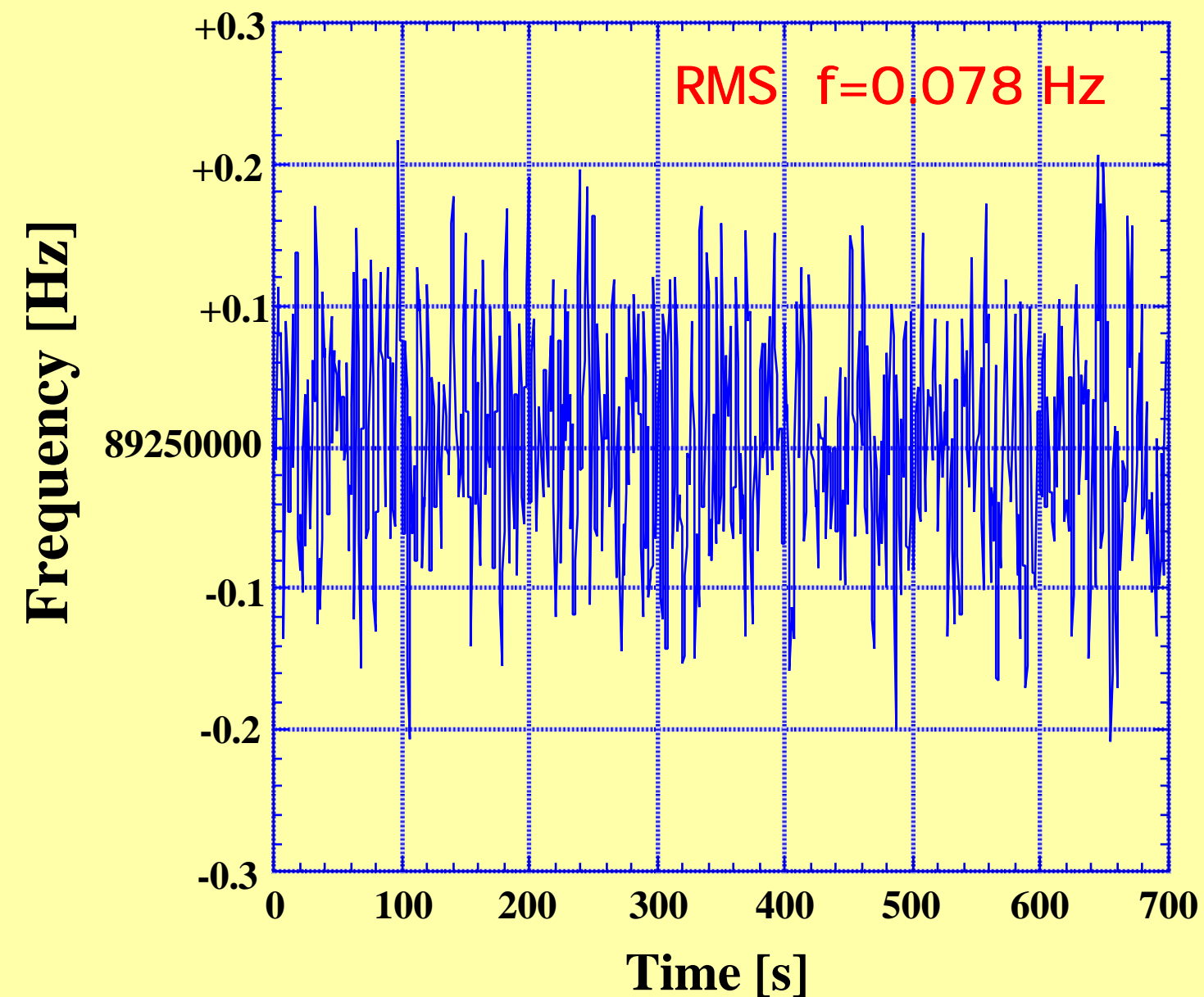
Emittance: 2.3 π mm mrad



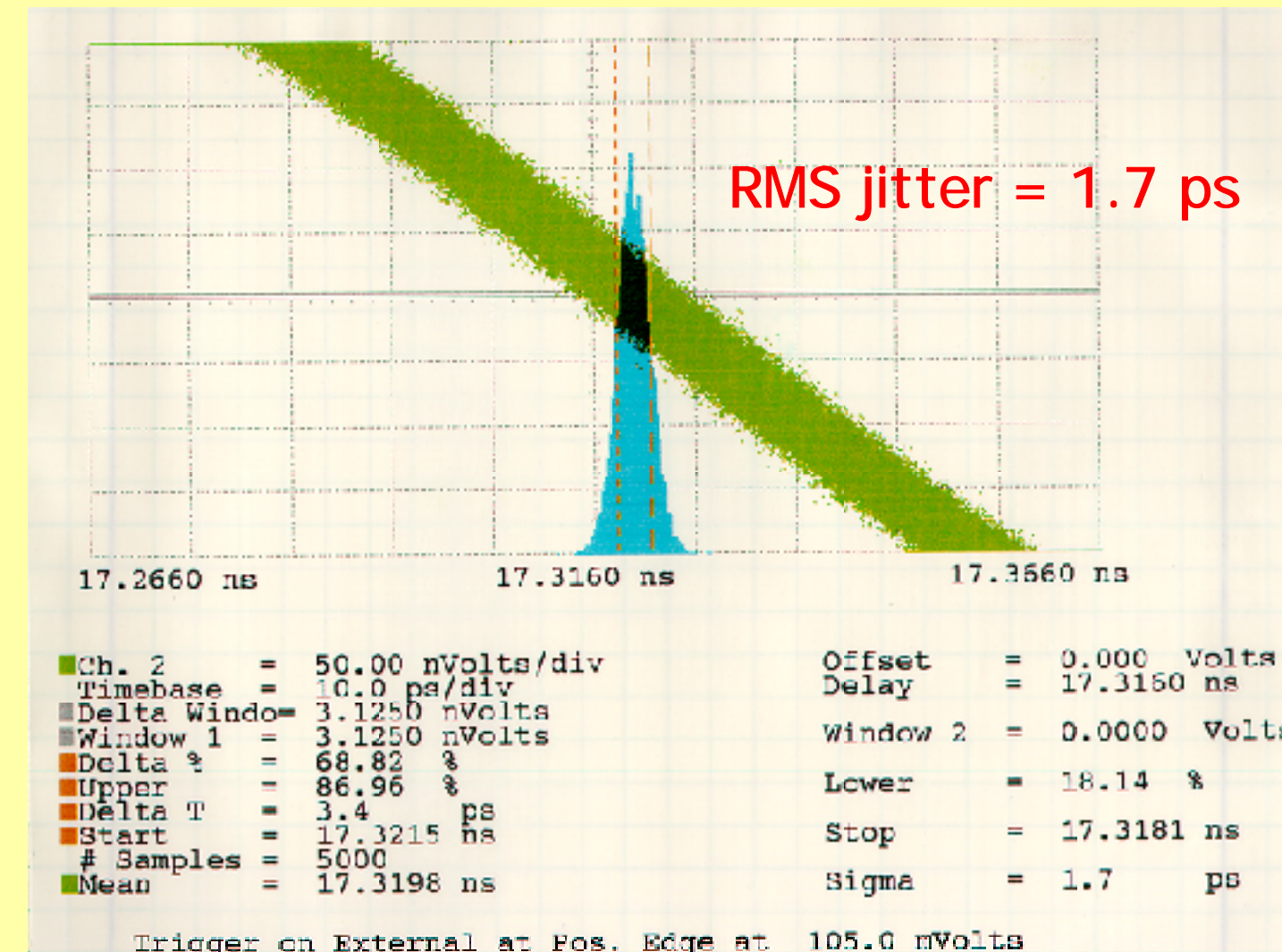
Synchronization System



Measurement of Synchronization

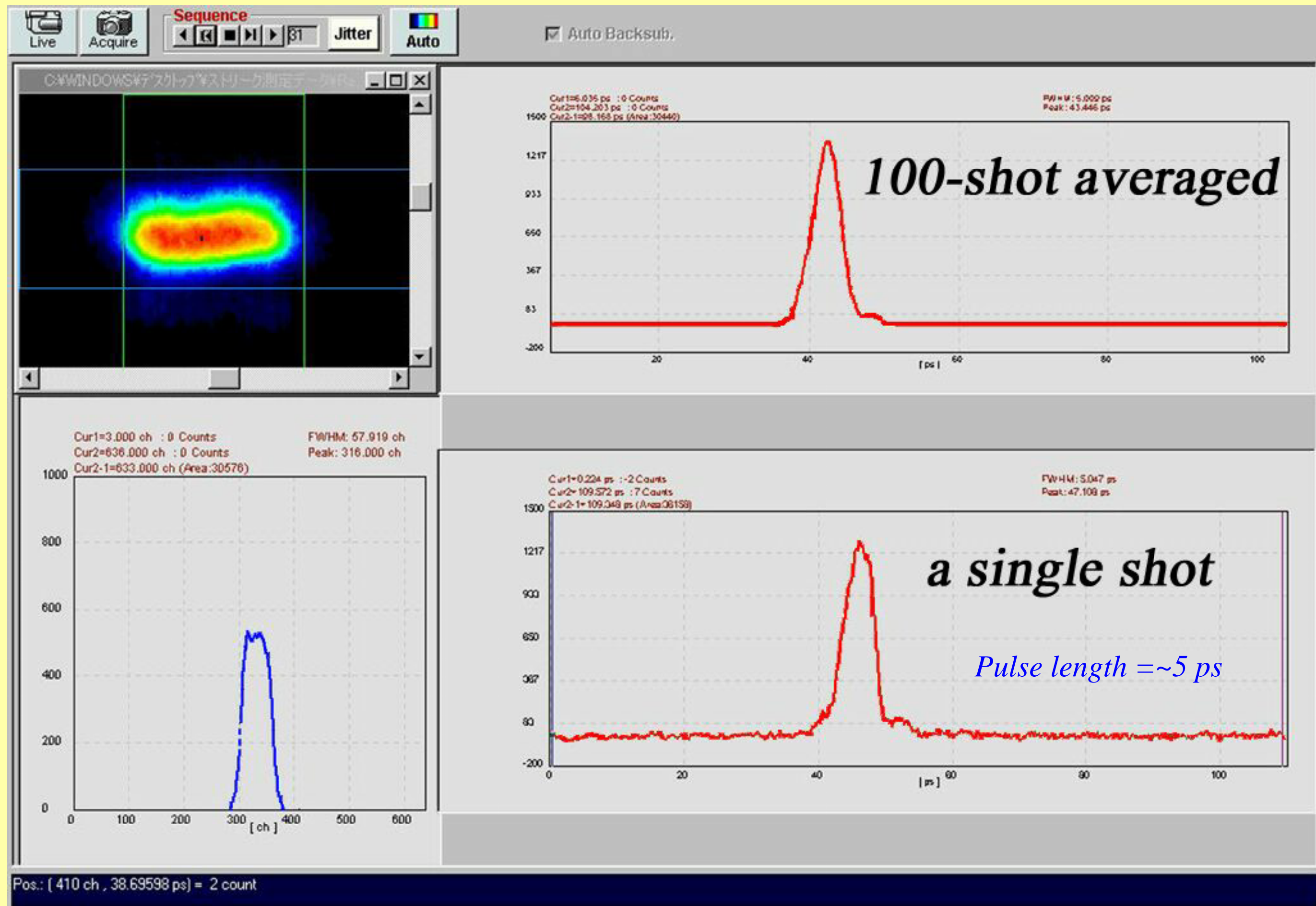


Laser Frequency Stability



Jitter Measurement with Sampling Oscilloscope

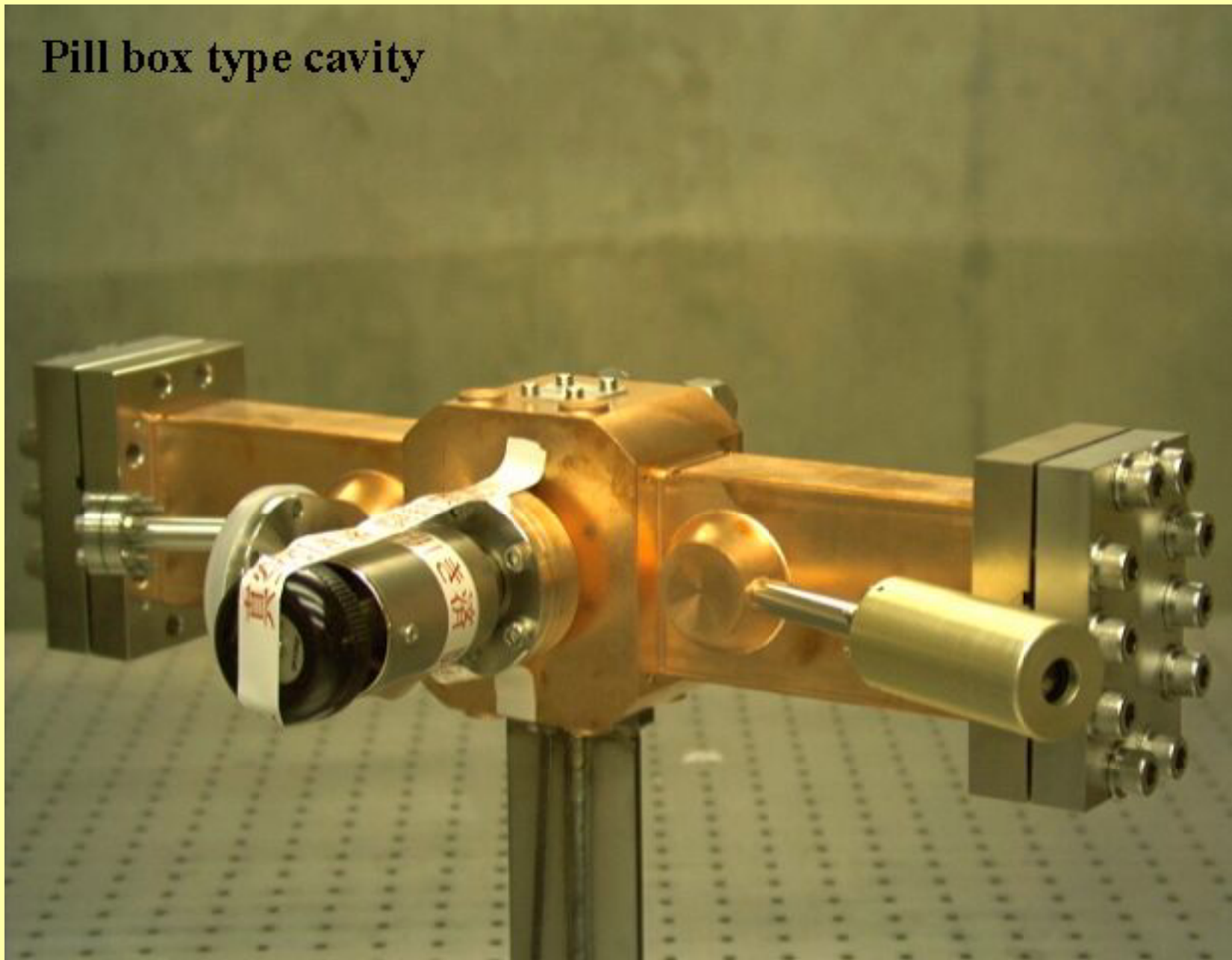
Measurement of Laser Pulse Length with Streak Camera



RF System & RF cavity

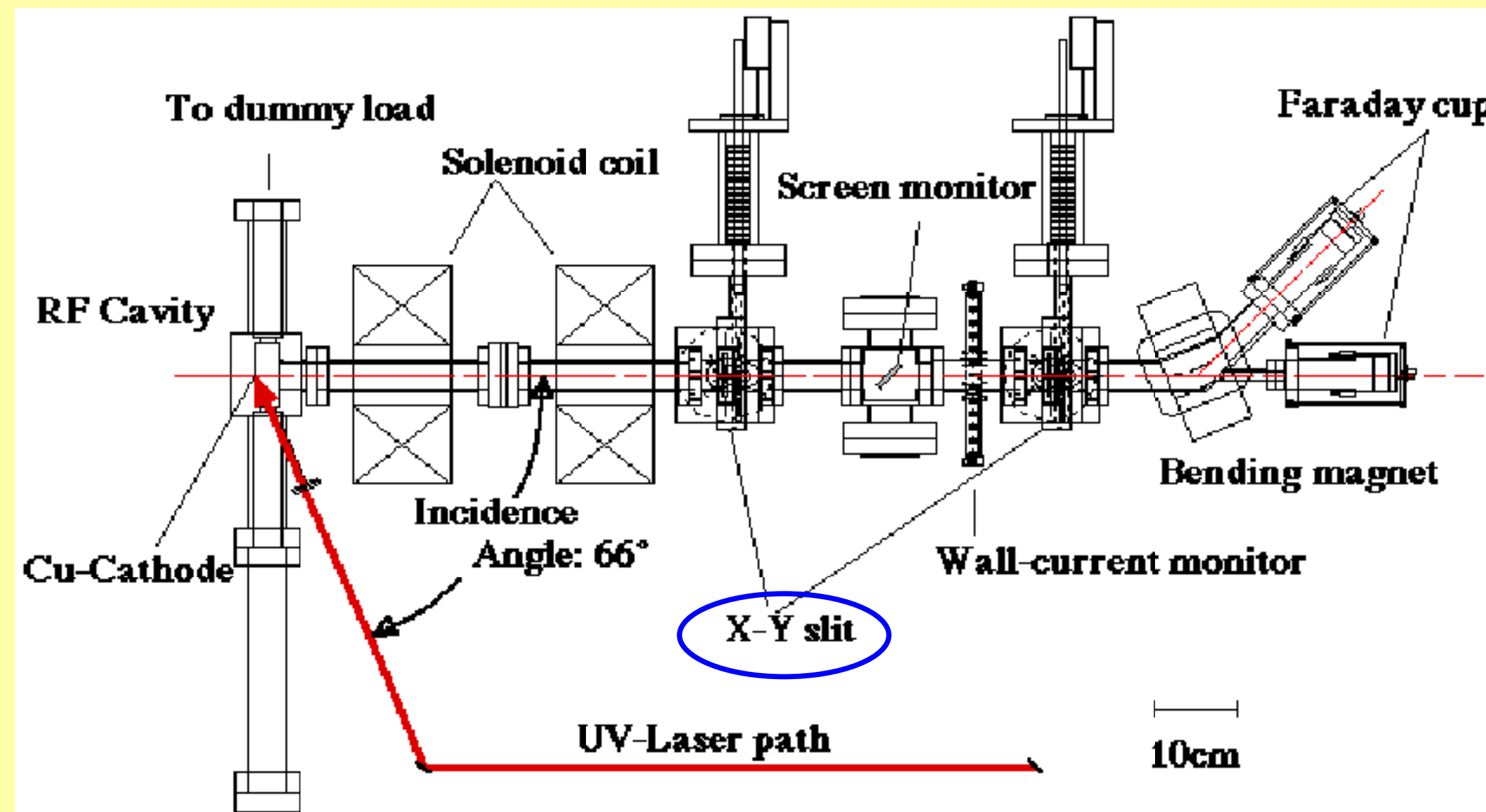


Klystron	
Type	Toshiba E3712
Maximum Power	80MW
Repetition Rate	10Hz (Max 60Hz)



Cavity	
Type	Single cell (Pill box type)
RF wave in the cavity	Standing wave
Maximum Electric Field on cathode	175 MV/m
Acceleration gap Length	28 mm
Maximum Beam Energy	4.1 MeV

Beam Emittance Measurement with double slits

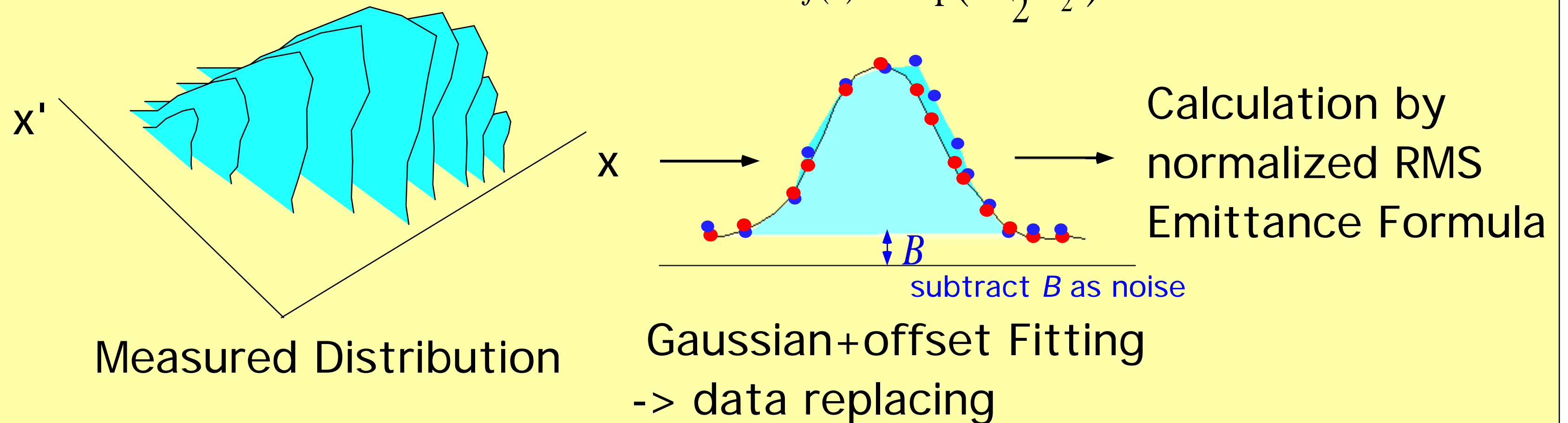


Adjusted or Optimized Parameters

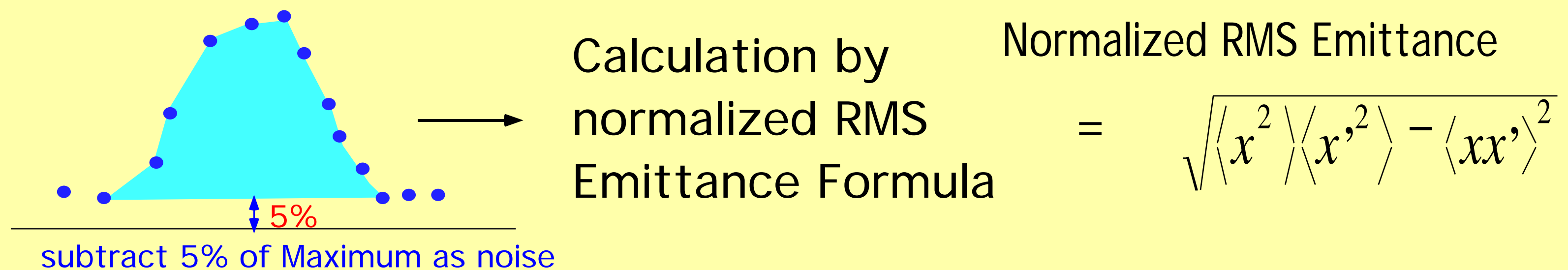
- RF phase
- Magnetic Field of Solenoids
- Laser Profiles
- Laser Spot size
- Laser position
- Laser pulse energy

Data Analysis of Beam Emittance Measurement

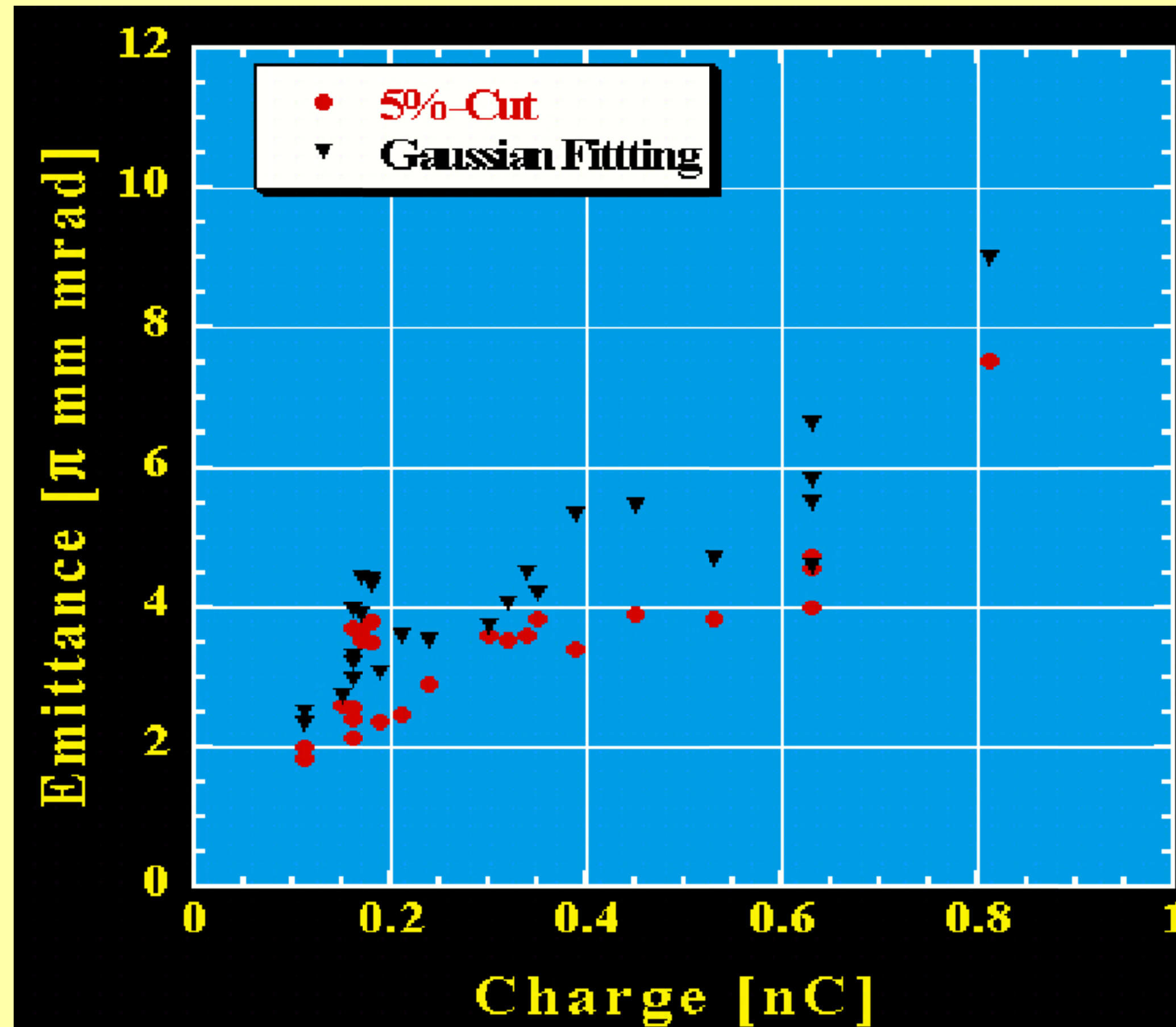
Analysis 1 Gaussian Fitting



Analysis 2 Direct Evaluation (fast but inaccurate)

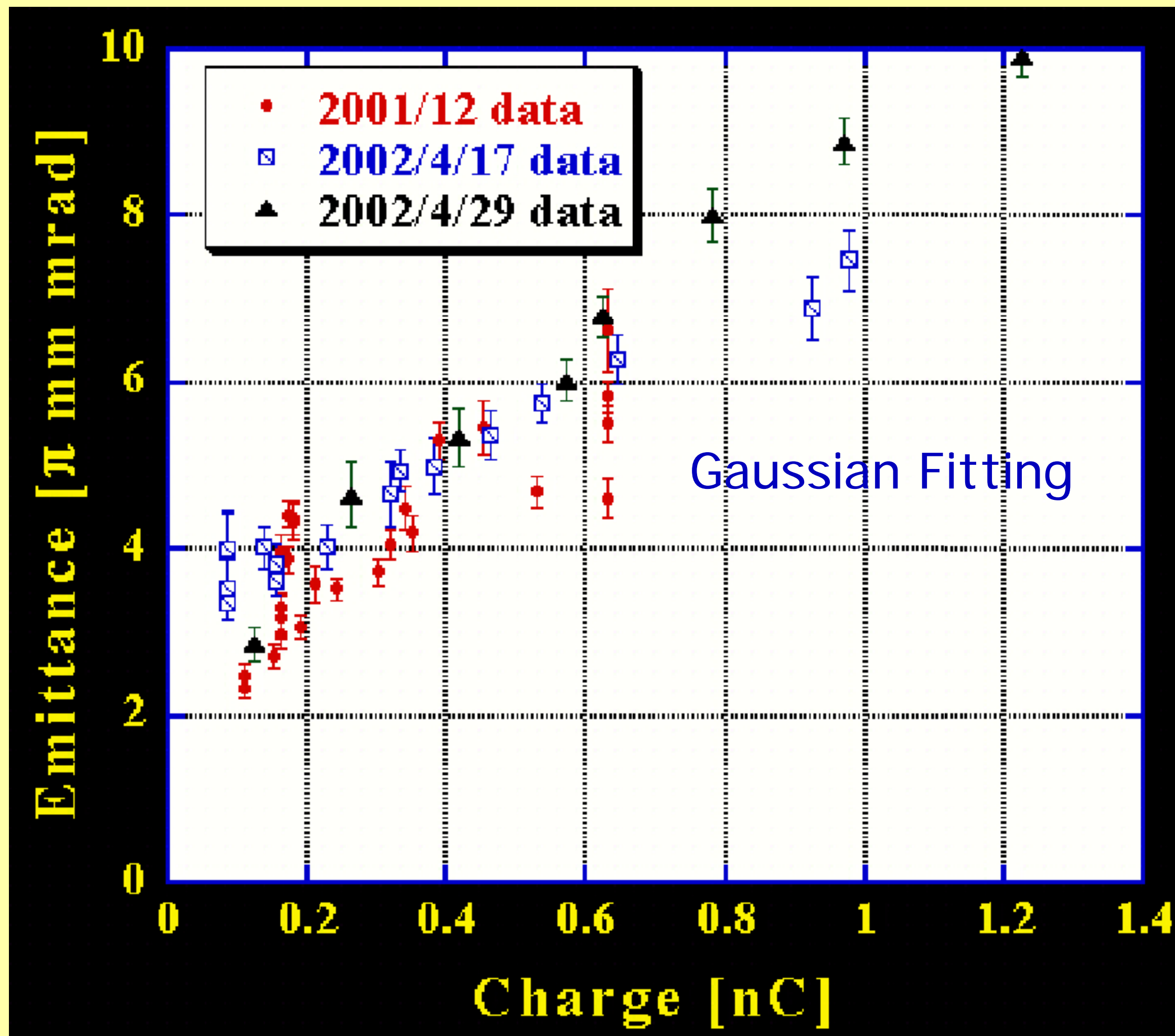


Comparison between different data analyses of Emittance Measurements

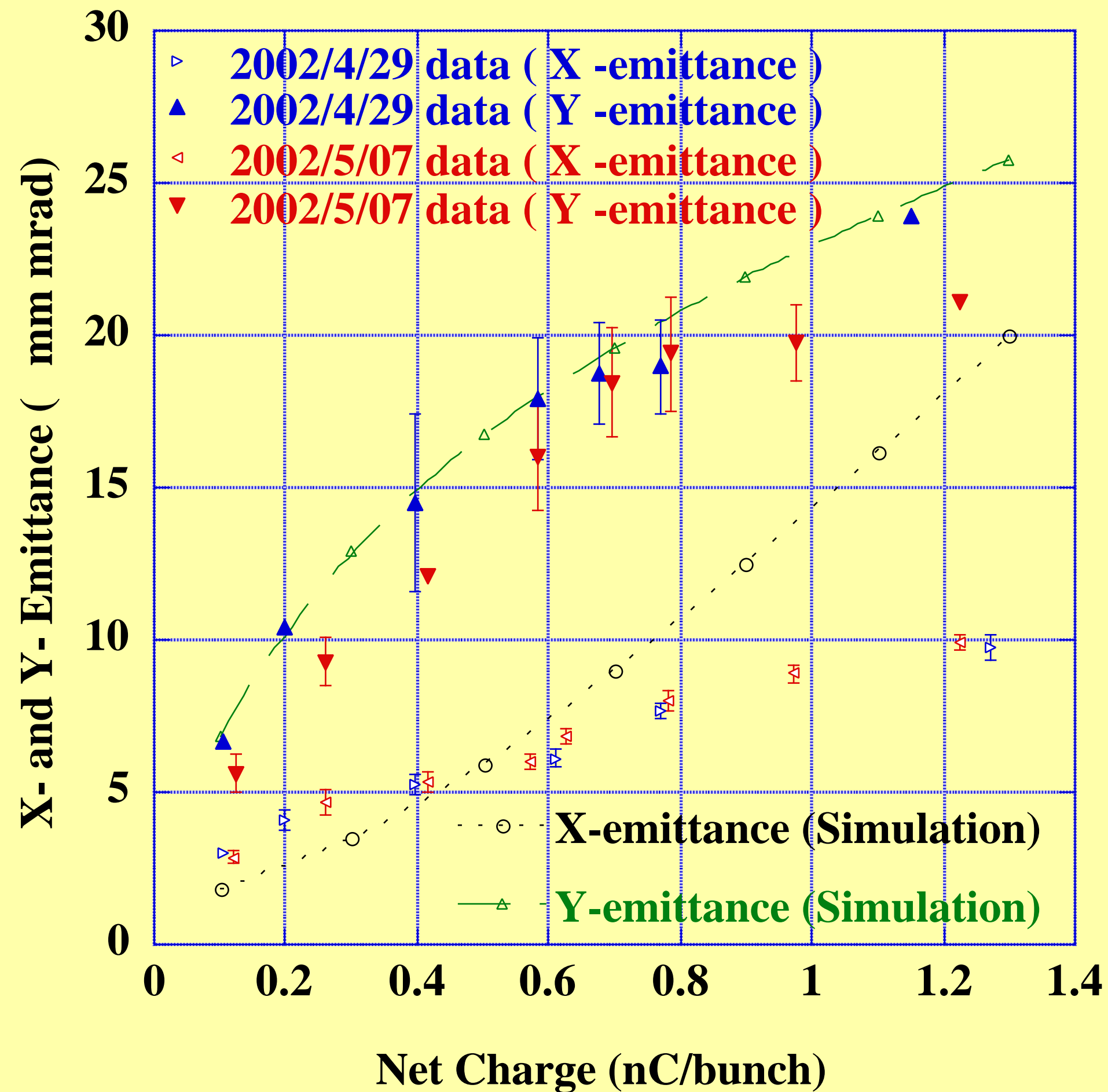


(Gaussian Fitting) > (Direct, 5% cut)

Charge dependences of Beam Emittance



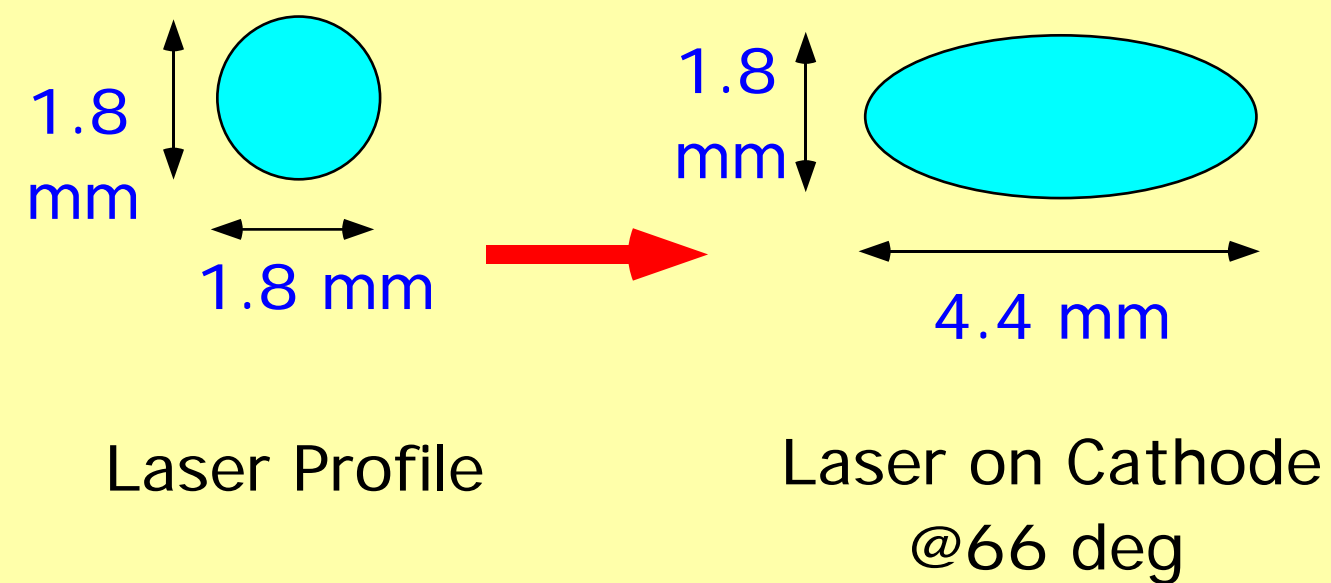
Comparison of horizontal(X) and vertical(Y) beam emittance



$y > x$

Effect of Laser Incident Angle

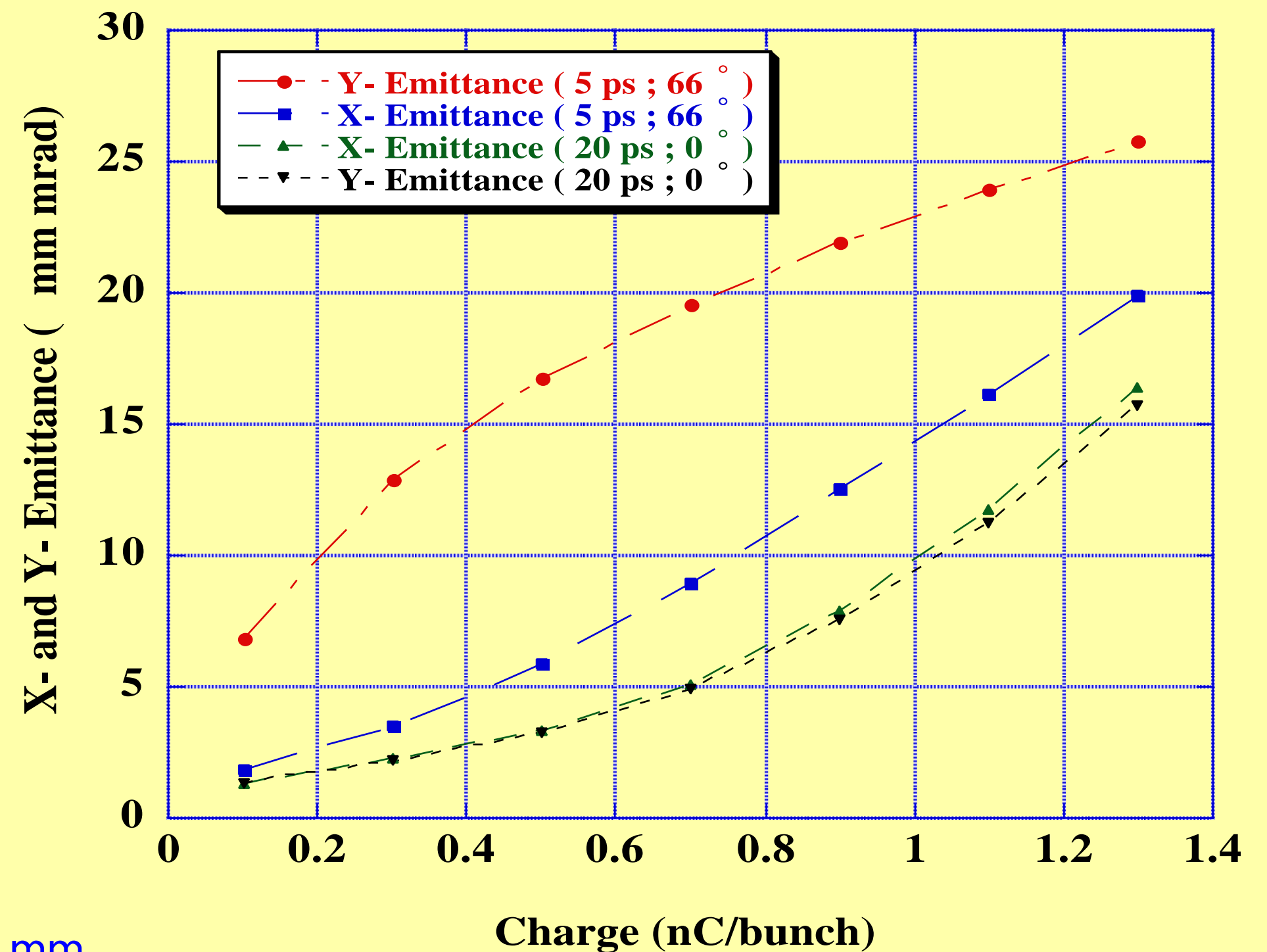
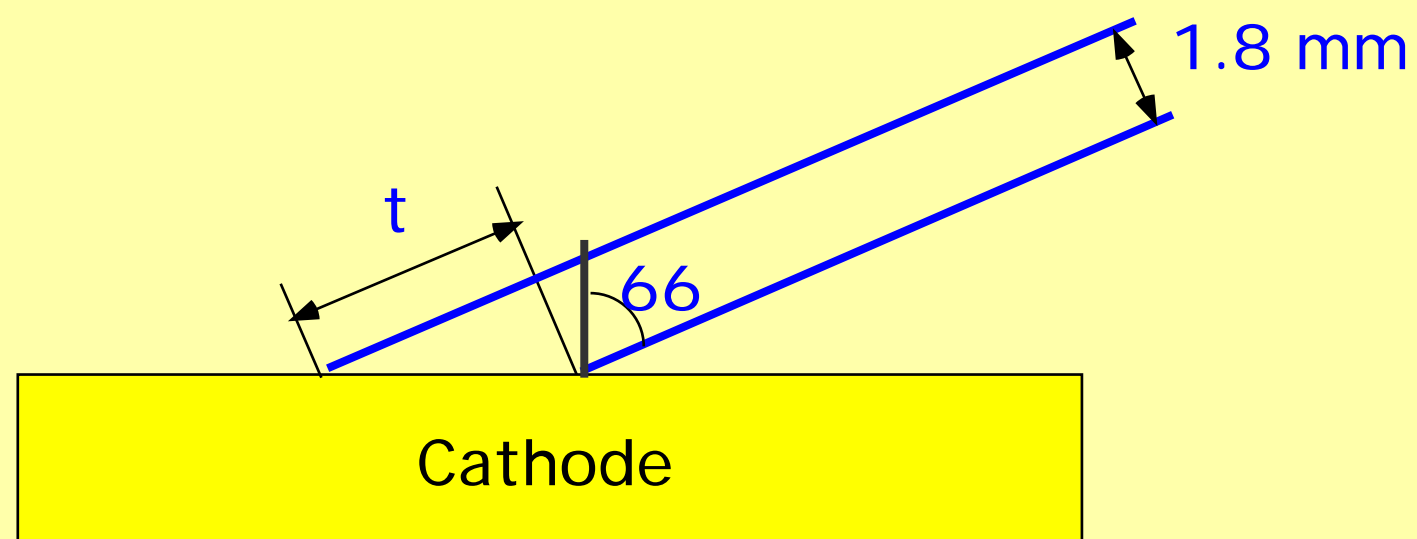
1 Laser spot size on cathode



2 Time delay on cathode

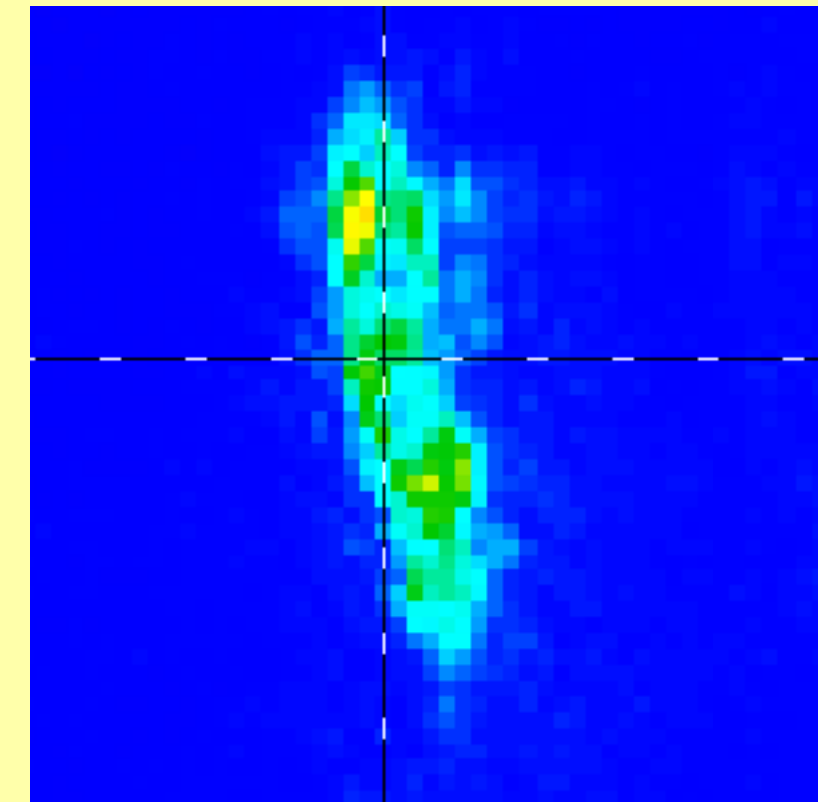
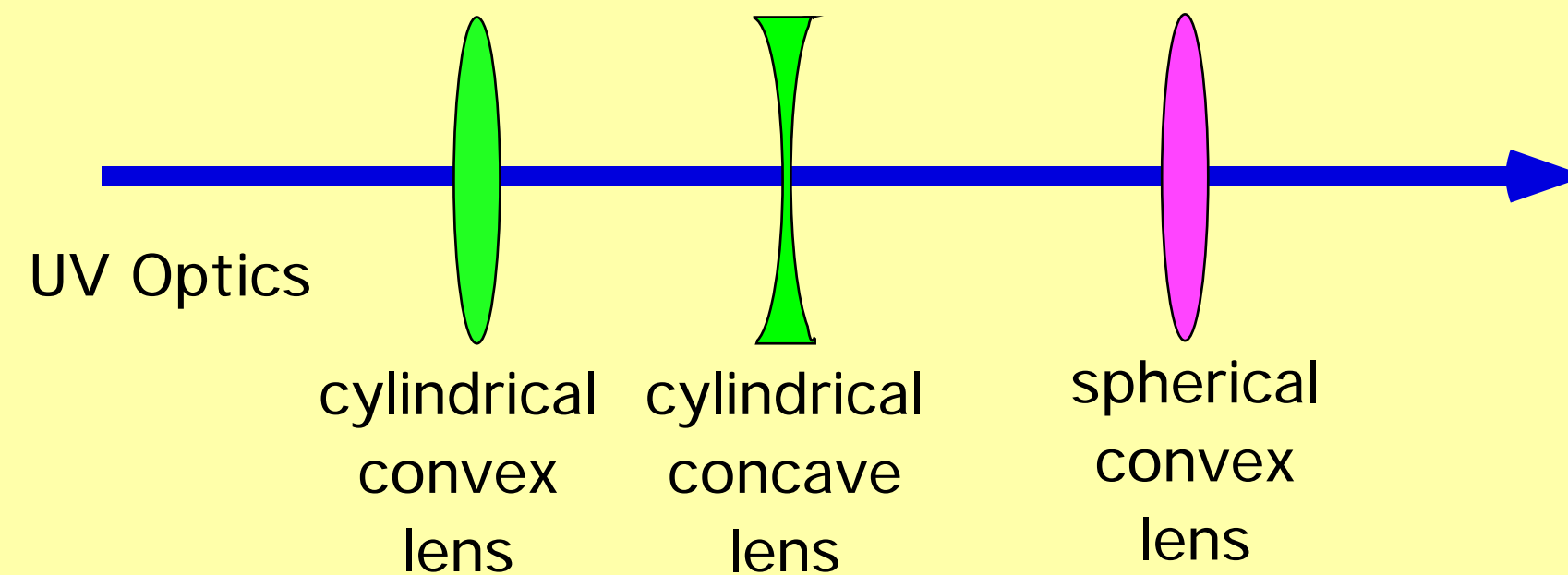
$t = 0.0 \text{ ps}$ (0 deg)

$t = 13.4 \text{ ps}$ (66 deg)

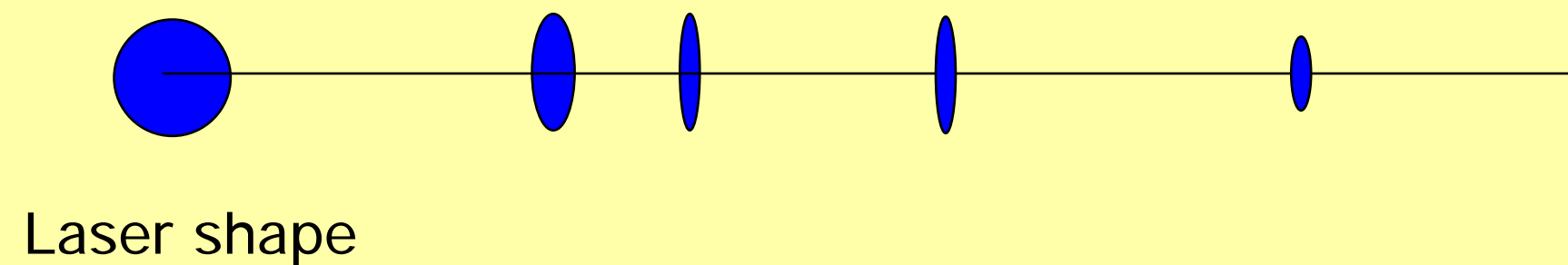


Results of Simulation for the cases of incident angle of 0 and 66 degree.

Laser beam transformation to ellipsoidal shape with cylindrical lens



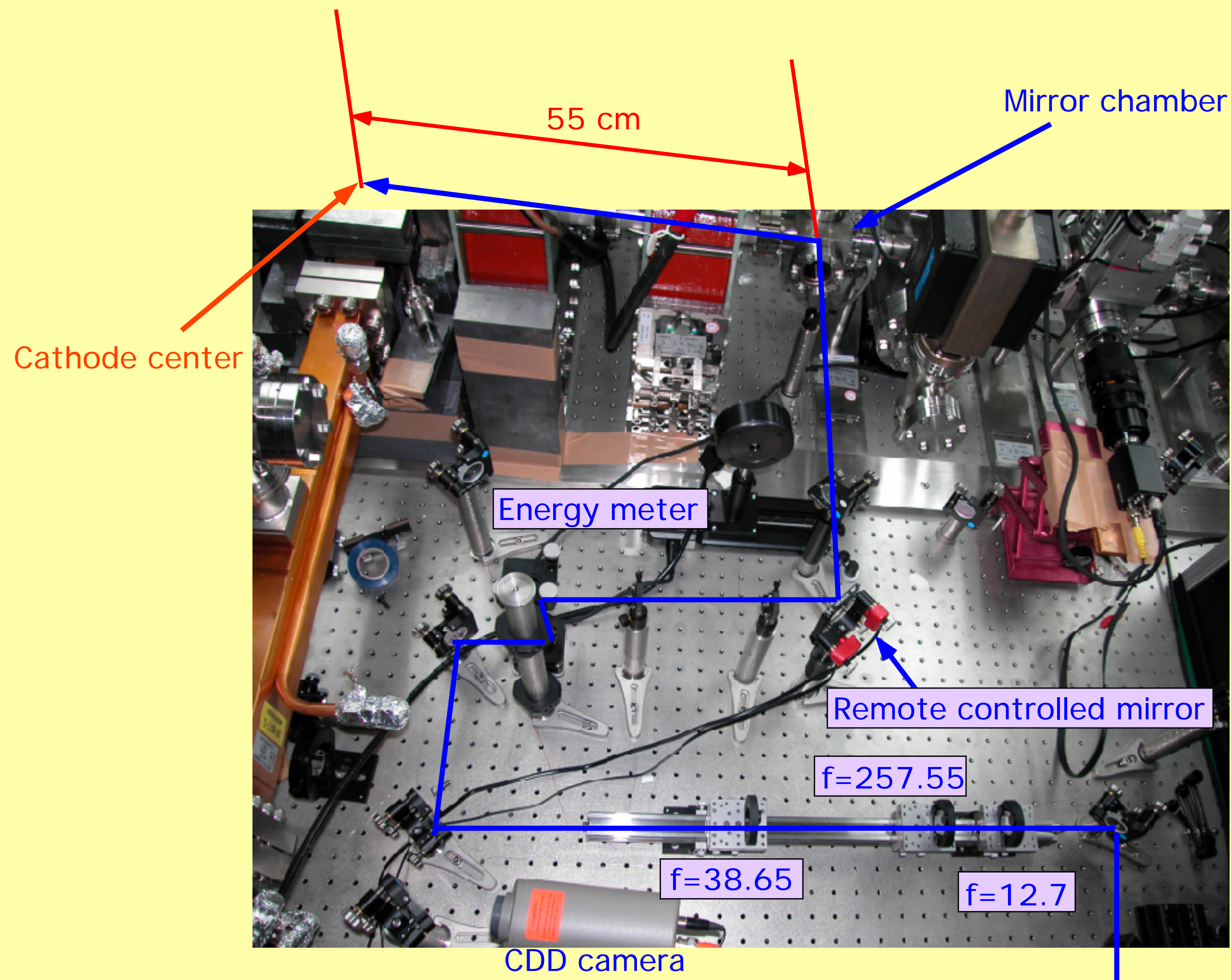
x 0.60 mm
y 1.89 mm



	circle(@0.1nC)	ellipse(@0.2nC)
x emittance	3.0	3.9
y emittance	6.6	5.4

Vertical emittance was improved.
Without homogenizer

Installation of zero-degree injection optics



Plans

1. Emittance measurement for 0° Injection
 2. Installation of accelerator tube after RF-gun
 3. Comparison between double slits & Q-scan
 4. Improve resolution of emittance measurement
 5. Beam pulse length measurement
 6. RF generation without pulse generator--> low jitter
 7. Faster feedback of piezo mirror (PLL)
 8. Temporal profile optimization
- etc..

Summary

1. Laser Homogenizer succeeded.
Laser energy fluctuation < 2 %
2 mmmrad @0.1 nC
- 2 Good synchronization with generating RF from laser pulse.
RMS jitter < 1.7 ps.
3. Effect of non-right angle injection was investigated.
Vertical emittance > Horizontal emittance @66 deg
4. Ellipsoidal laser profile was formed with cylindrical lens.
5. Vertical emittance was improved with ellipsoidal laser profile.